

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L2	61	(((((rapid\$3 anneal\$6 heat\$6 treatment) near thermal\$3) rta rtp rtn rto) and ((wafer substrate) near4 (rotat\$6 spin\$6 turn\$6))). clm.	US-PGPUB	OR	ON	2005/09/14 13:07
S1	2	jp-06260426-\$.did.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2005/09/13 12:50
S2	556	438/782.ccls.	US-PGPUB; USPAT	OR	OFF	2005/09/13 14:20
S3	6	((rapid\$3 near thermal\$3) rta rtp rtn rto) same ((wafer substrate) near4 (rotat\$6 spin\$6 turn\$6)) same (loop near4 (control\$6 close\$3 open\$3))	US-PGPUB; USPAT	OR	ON	2005/09/13 13:00
S5	50	((rapid\$3 near thermal\$3) rta rtp rtn rto) and ((wafer substrate) near4 (rotat\$6 spin\$6 turn\$6))	EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/13 16:38
S6	167	((rapid\$3 near thermal\$3) rta rtp rtn rto) same (loop with (control\$6 close\$3 open\$3))	US-PGPUB; USPAT	OR	ON	2005/09/13 13:01
S8	7	((rapid\$3 near thermal\$3) rta rtp rtn rto) same ((wafer substrate) near4 (rotat\$6 spin\$6 turn\$6)) same (loop with (control\$6 close\$3 open\$3))	US-PGPUB; USPAT	OR	ON	2005/09/13 13:02
S9	17	((rapid\$3 near thermal\$3) rta rtp rtn rto) and (loop with (control\$6 close\$3 open\$3))	EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/13 13:58
S10	2193	438/308.ccls. 438/457.ccls. 438/663.ccls. 438/771.ccls. 438/776.ccls. 438/782.ccls. 438/795.ccls.	US-PGPUB; USPAT	OR	OFF	2005/09/13 14:03
S11	573	S10 and ((rapid\$3 near thermal\$3) rta rtp rtn rto)	US-PGPUB; USPAT	OR	ON	2005/09/13 14:03
S12	111	S11 and ((wafer substrate) near4 (rotat\$6 spin\$6 turn\$6))	US-PGPUB; USPAT	OR	ON	2005/09/14 08:11
S13	3	"5965047".pn. "6005226".pn. "5920797".pn.	US-PGPUB; USPAT	OR	OFF	2005/09/14 08:12
S14	81	((rapid\$3 near thermal\$3) rta rtp rtn rto) same (loop with control\$6 with (close\$3 open\$3))	US-PGPUB; USPAT	OR	ON	2005/09/14 08:20
S15	404	((rapid\$3 near thermal\$3) rta rtp rtn rto) same ((wafer substrate) near4 (rotat\$6 spin\$6 turn\$6))	US-PGPUB; USPAT	OR	ON	2005/09/14 13:05